

# Stabilizing Metastable Rare-Earth Ferrites on (111) Platinum via an Iron Oxide Interlayer

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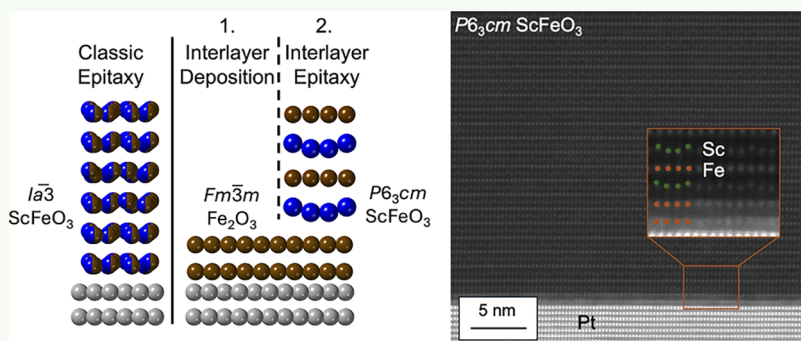
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**ABSTRACT:** The metastable  $P6_3cm$  phase of  $ScFeO_3$  (h- $ScFeO_3$ ) is a multiferroic material, but instability on conductive substrates limits the development of next-generation memory and magnetoelectric sensors. Unfortunately, stabilization approaches developed for insulating substrates, such as sapphire, do not translate directly to conductive substrates. In this work, we demonstrate how interlayer design preferentially stabilizes h- $ScFeO_3$  on (111) platinum via molecular beam epitaxy while simultaneously enhancing key figures of merit. We developed a process to deposit a (111) wüstite-like interlayer with a metastable  $Fe^{3+}$  oxidation state to target h- $ScFeO_3$ . The films are solely (0001) oriented h- $ScFeO_3$  without any measured secondary phases. Rocking curves of the 0004 h- $ScFeO_3$  peak have a full width at half-maximum of  $0.06^\circ$ , an improvement compared to films deposited without this interlayer approach. A further indication of strain reduction in these films is structural distortion in the first layers of h- $ScFeO_3$ , overcoming the critical thickness limit in h- $ScFeO_3$ . Designing interlayers to reduce epitaxial strain and target specific phases expands the viable substrates for metastable materials and overcomes the thickness limits for improper ferroelectricity.

**KEYWORDS:** Interface, metastable, molecular beam epitaxy, thin film, functional materials, ferroelectric, multiferroic

## INTRODUCTION

The  $P6_3cm$  phase of  $ScFeO_3$  (h- $ScFeO_3$ ) is simultaneously ferroelectric and antiferromagnetic,<sup>1,2</sup> making it ideal for many multiferroic applications, such as scalable magnetoelectric spin–orbit logic and magnetic biosensing.<sup>3,4</sup> Thin films of h- $ScFeO_3$  have the highest reported Néel transition temperature of rare-earth ferrites, up to 195 K,<sup>1</sup> while maintaining improper ferroelectricity up to 681 K.<sup>2,5</sup> Because the h- $ScFeO_3$  phase is metastable and in competition with four other known polymorphs, routes to preferentially select and stabilize this phase are necessary.<sup>6</sup> Stromataxic and interlayer stabilization have been developed to stabilize h- $ScFeO_3$  and analogous structures,<sup>5,7,8</sup> but these methods were developed for non-conductive substrates, such as  $Al_2O_3$ . Unfortunately, depositing h- $ScFeO_3$  on the conductive substrates needed for multiferroic applications induces secondary phases or destabilizes this phase completely.<sup>1</sup> Conductive substrates are needed for many multiferroic logic and sensors to extract charge or apply voltage to the material. While  $ScFeO_3$  deposited on oxide electrodes

has enabled the study of the intrinsic properties of h- $ScFeO_3$  (magnetic properties, ferroelectric switching),<sup>1,2</sup> a critical next step to expand the applications of h- $ScFeO_3$  is to stabilize the phase on device-compatible conductive substrates.

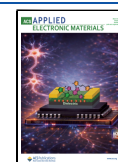
Scaling down the film thickness while maintaining polar distortion is critical to meet device scaling needs; however, interfacial clamping due to strain is an external limit to the critical thickness for polarization in improper ferroelectric materials like h- $ScFeO_3$ .<sup>5,9,10</sup> Therefore, stabilizing h- $ScFeO_3$  on a highly conductive substrate, such as (111) Pt, while simultaneously developing interlayers to decrease interfacial clamping is a critical step toward the application of h- $ScFeO_3$

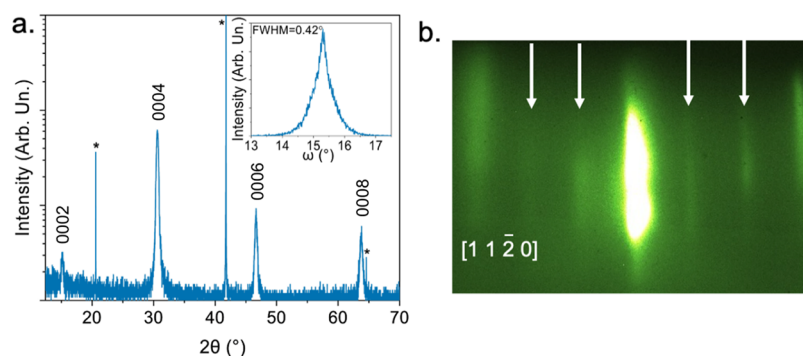
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**Figure 1.** (a) XRD pattern of a h-ScFeO<sub>3</sub> film deposited on (0001) Al<sub>2</sub>O<sub>3</sub>. Reflections marked with 0002 $\bar{1}$  are from the  $P6_3cm$  phase and reflections marked with \* are from the substrate; inset rocking curve measurement of the 0004 h-ScFeO<sub>3</sub> reflection; (b) RHEED taken along the h-ScFeO<sub>3</sub> [1 1  $\bar{2}$  0] direction after cooling. Arrows indicate the reconstruction from the scandium displacement.

as an exemplary improper ferroelectric.<sup>5,11</sup> Introducing an interlayer between a film and the substrate has long been used for interface strain mitigation,<sup>12</sup> but further work is needed to understand the design criteria for using interlayers to select specific metastable phases. We have previously shown that h-ScFeO<sub>3</sub> is stabilized on Al<sub>2</sub>O<sub>3</sub> substrates by a wüstite iron oxide interlayer that forms spontaneously during deposition.<sup>8</sup> The mechanisms of stabilization are proposed to be due to the similar oxygen sublattice between the wüstite iron oxide interlayer and the h-ScFeO<sub>3</sub>, the similar iron oxide layer structure, and the low calculated epitaxial strain (3.67% for h-ScFeO<sub>3</sub> 11 $\bar{2}$ 0 || Fe<sub>x</sub>O  $\bar{1}$ 12).<sup>8</sup> Unfortunately, wüstite does not spontaneously form or precipitate out naturally on conductive substrates, potentially due to charge transfer and changes in lattice mismatch.<sup>13</sup> Wüstite iron oxide would be compatible with deposition on several conductive materials, including (111) Pt, on which it can form in a metastable Fe<sup>3+</sup> oxidation state.<sup>13–16</sup> Therefore, it is necessary to intentionally design a chemically and structurally compatible interlayer deposition approach that can be translated to conductive substrates and reduce interfacial clamping.

This work investigates how to design an interlayer to stabilize the metastable  $P6_3cm$  phase of ScFeO<sub>3</sub> on conductive substrates. We hypothesize that depositing a wüstite Fe<sub>2</sub>O<sub>3</sub> interlayer on (111) Pt will preferentially stabilize the h-ScFeO<sub>3</sub> phase because of the similar oxygen sublattice with h-ScFeO<sub>3</sub> and flexible bond coordination in Fe<sub>2</sub>O<sub>3</sub>. To test this hypothesis, the phase formations of ScFeO<sub>3</sub> films deposited both with and without a wüstite Fe<sub>2</sub>O<sub>3</sub> interlayer are compared. We find that on (111) platinum, only films deposited with a wüstite bilayer form the  $P6_3cm$  phase of ScFeO<sub>3</sub>. We further developed a process to suppress the formation of secondary phases, resulting in highly crystalline h-ScFeO<sub>3</sub>. Furthermore, the overlap of the oxygen sublattices and the low epitaxial strain reduce the interfacial clamping compared to previous reports, paving the way to reducing the critical thickness of ferroelectric devices.

## RESULTS AND DISCUSSION

Given that the  $P6_3cm$  phase of ScFeO<sub>3</sub> (h-ScFeO<sub>3</sub>) is metastable, the first step is to determine the deposition conditions necessary to stabilize the phase. Since Al<sub>2</sub>O<sub>3</sub> has previously been observed to stabilize h-ScFeO<sub>3</sub>,<sup>6–8</sup> initial depositions focus on this substrate. The scandium and iron fluxes were alternated to promote the stabilization of the layered h-ScFeO<sub>3</sub> phase using a procedure adapted from

reference.<sup>7</sup> Figure S1a shows the X-ray diffraction (XRD) of a ScFeO<sub>3</sub> film deposited at 500 °C. At or below 500 °C, the peaks observed in XRD fit to the ground state bixbyite ScFeO<sub>3</sub> phase. Increasing the temperature above 800 °C leads to the formation of the  $P6_3cm$  phase. The X-ray diffraction (XRD) of a representative h-ScFeO<sub>3</sub> thin film deposited on Al<sub>2</sub>O<sub>3</sub> at 900 °C is shown in Figure 1a. The diffraction pattern exhibiting 0002 $\bar{1}$  fits to the  $P6_3cm$  phase of ScFeO<sub>3</sub> with a (0001) orientation.<sup>17</sup> The rocking curve, taken from the 0004 h-ScFeO<sub>3</sub> peak, in the inset of Figure 1a, demonstrates the degree of crystallographic alignment of the film. The full width at half-maximum (FWHM) of the rocking curve is 0.42°, on par with the lowest values currently reported in literature, 0.4°.<sup>17</sup>

Reflection high-energy electron diffraction (RHEED) taken during deposition further corroborates the formation of the  $P6_3cm$  phase. Figure 1b shows the RHEED along the h-ScFeO<sub>3</sub> [1 1  $\bar{2}$  0] direction from the same film in Figure 1a after 60 min of deposition and cooling to room temperature. The  $\pm(3n + 1)/3$  and  $\pm(3n + 2)/3$  diffraction streaks (highlighted with the white arrows) are clear indications of the  $\sqrt{3} \times \sqrt{3}$  reconstruction in the  $a$ – $b$  plane induced by the structural distortion of the scandium atoms associated with the  $P6_3cm$  phase.<sup>5</sup> These distinctive reconstructions have previously been reported for many isostructural complex transition metal oxides.<sup>5,18</sup> The RHEED also provides a clear means to differentiate between the metastable hexagonal phase and bixbyite ground state because the ground state has a clearly different in-plane diffraction pattern, like that seen for the predominantly bixbyite ScFeO<sub>3</sub> films deposited at 500 °C in Figure S1b.

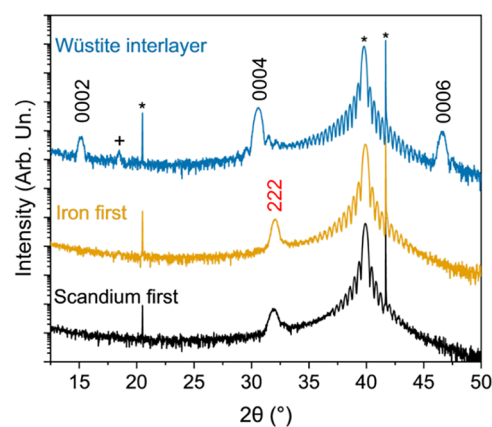
Another indication of the quality of the films is the low surface roughness of the h-ScFeO<sub>3</sub> films deposited onto sapphire substrates. Figure S2 shows 5 × 5 μm atomic force microscopy (AFM) images taken from the surface of an h-ScFeO<sub>3</sub> film. The average surface roughness ( $R_a$ ) of the films is approximately 0.5 nm, which is on par with previous reports of other high-quality oxide films deposited by MBE.<sup>19,20</sup>

Unfortunately, the same conditions that stabilize the  $P6_3cm$  phase of ScFeO<sub>3</sub> on Al<sub>2</sub>O<sub>3</sub> result in the ground state bixbyite phase when the films are deposited onto a metallic substrate, such as (111) Pt.<sup>1</sup> Figure S3a,b show the XRD and RHEED patterns for these ScFeO<sub>3</sub> films deposited under the same conditions as those used for the sample shown in Figure 1a. On platinum substrates, the films form in the bixbyite phase under the same conditions that resulted in stabilization of the

$P6_3cm$  phase on  $Al_2O_3$ . The platinum films have different emissivity and thermal conductivity than sapphire, which suggests that a different range of deposition temperatures could be used to reach the same phase. Nonetheless, adjusting the temperature from 700 to 1100 °C still results in only the ground state bixbyite phase, as seen by the RHEED in Figure S3c,d. The inability to stabilize h-ScFeO<sub>3</sub> on platinum is unexpected, given the closer one-dimensional lattice mismatch of −3.4% compared to −17.1% on  $Al_2O_3$ . However, our prior work has shown that when ScFeO<sub>3</sub> is deposited onto  $Al_2O_3$ , an interlayer of (111)-oriented wüstite  $Fe_xO$  bilayer forms that then stabilizes h-ScFeO<sub>3</sub> by providing a matching iron–oxygen sublattice.<sup>8</sup> These results suggest that the stabilization mechanism that occurs on  $Al_2O_3$  does not intrinsically occur on platinum.<sup>8,21</sup> Thus, we propose to intentionally design an iron oxide interlayer that will preferentially stabilize h-ScFeO<sub>3</sub> on conductive substrates. While the magnitude of the one-dimensional lattice mismatch of h-ScFeO<sub>3</sub> on (111) wüstite (3.6%) is comparable to that of h-ScFeO<sub>3</sub> on (111) Pt (−3.4%), adding a wüstite iron oxide interlayer is predicted to preferentially select for the h-ScFeO<sub>3</sub> phase because of the coordination and bonding flexibility of the iron.<sup>21</sup> Additionally, the similarity between the oxygen sublattice between the interlayer and h-ScFeO<sub>3</sub> has been observed to preferentially stabilize the desired metastable phase.

Depositing an interlayer should stabilize the phase; however, the (111) wüstite FeO that forms on  $Al_2O_3$  does not form under the same conditions as on platinum. While the wüstite phase of FeO is stable on  $Al_2O_3$  at substrate temperatures above 250 °C,<sup>22,23</sup> the reported process for stabilization is different on (111) Pt.<sup>14,15</sup> Furthermore, the oxidation state of the wüstite phase can range from a stable  $Fe^{2+}$  oxidation state to a metastable  $Fe^{3+}$  oxidation state depending on the oxidizing species used. To deposit  $Fe_xO$  on (111) Pt films, a two-step process is used—metallic iron is first deposited at room temperature and then subsequently oxidized at temperatures above 600 °C.<sup>8,14–16,23</sup> We use a similar approach here to target the deposition of a two-atomic-layer-thick, (111)-oriented, wüstite iron oxide interlayer by adapting the methods from Ritter et al.<sup>14</sup> A differentiating factor in this work is that an 80% ozone source is used to target the  $Fe^{3+}$  oxidation state to match the oxidation state of the interlayer and h-ScFeO<sub>3</sub>, aiming to reduce the mismatch between the interlayer and film. The formation of the wüstite iron oxide interlayer is evident in the RHEED images in Figure S4a,b. The RHEED patterns, taken after oxidation along the  $Fe_2O_3$   $[1\bar{1}0]$  and  $[11\bar{2}]$ , match those previously reported for wüstite  $Fe_2O_3$ .<sup>23</sup> AFM images of the platinum substrate (Figure S4c) and the iron oxide interlayer (Figure S4d) both have an  $R_a = 0.3$  nm, confirming that the low surface roughness of the substrate is maintained following interlayer deposition. Now that we have achieved the desired (111)-oriented wüstite iron oxide interlayer, the next step is to determine if this phase will provide a platform for the stabilization of h-ScFeO<sub>3</sub>.

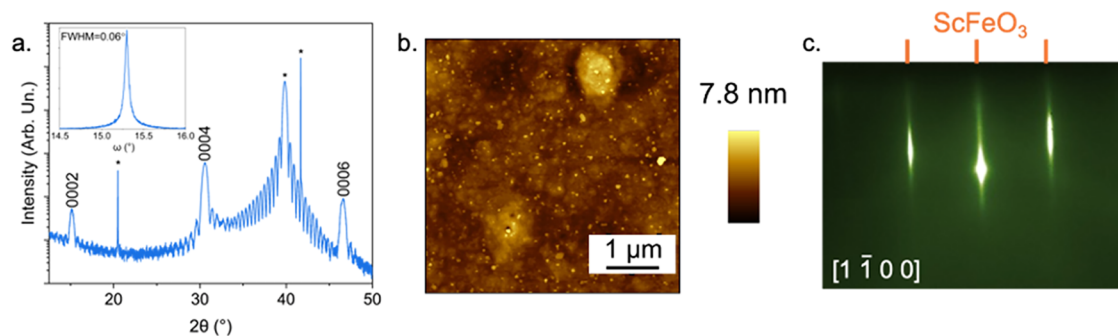
From the XRD, we see that our hypothesis is correct that an intentional addition of a (111)-oriented wüstite iron oxide interlayer stabilizes the h-ScFeO<sub>3</sub> phase. Figure 2 highlights the importance of depositing the  $Fe_2O_3$  interlayer to stabilize the  $P6_3cm$  phase of ScFeO<sub>3</sub>. Starting the deposition onto Pt with a single layer of scandium oxide or iron oxide at 900 °C (deposition temperature) results in solely (111)-oriented bixbyite ScFeO<sub>3</sub>. Only after adding a (111) wüstite interlayer does the (0001)-oriented h-ScFeO<sub>3</sub> form. For films deposited



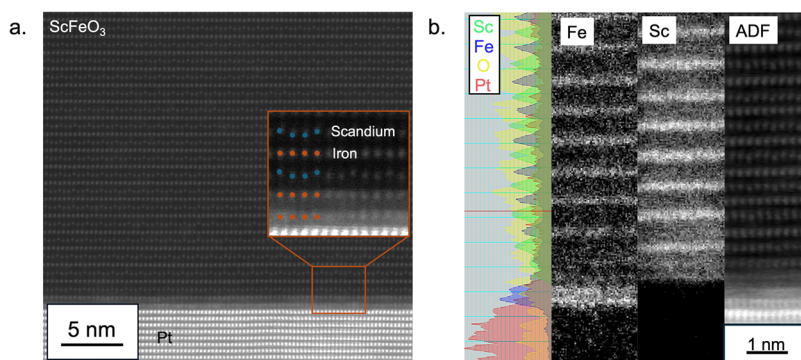
**Figure 2.** XRD patterns of ScFeO<sub>3</sub> films on (111) Pt-coated (0001)  $Al_2O_3$  substrates deposited with or without an intentional iron oxide interlayer. The 0002 reflections fit to h-ScFeO<sub>3</sub>, the  $hkl$  reflections are fit to bixbyite ScFeO<sub>3</sub>, the + reflections are fit to (111)  $Fe_3O_4$ , and the \* reflections are fit to (111) Pt and the  $Al_2O_3$  substrate.

onto an interlayer, no other secondary phases of ScFeO<sub>3</sub> are observed. However, there are peaks consistent with (111)-oriented  $Fd\bar{3}m$   $Fe_3O_4$  (PDF #01–080–6410).<sup>24</sup> The  $c$ -axis lattice parameter of the h-ScFeO<sub>3</sub> films deposited on the interlayer is calculated to be 11.7 Å, which matches the lattice parameter calculated for the film deposited on  $Al_2O_3$ . Stabilization is likely not solely due to epitaxial strain, as the −3.8% lattice mismatch between h-ScFeO<sub>3</sub> and the interlayer is larger in magnitude than the 3.2% lattice mismatch between h-ScFeO<sub>3</sub> and platinum. Therefore, the overlap between the oxygen sublattice of h-ScFeO<sub>3</sub> and the wüstite interlayer and the similarity in the iron sublattices also play a role in stabilization.<sup>8</sup> By developing this interfacial layer between ScFeO<sub>3</sub> and platinum, we stabilized h-ScFeO<sub>3</sub>, which is a critical step to expand the applications of this phase.

While using an interlayer that includes one or more elements from the desired phase is advantageous, as it can template growth due to similar sublattices, it can also lead to nonstoichiometry in subsequent films. In the films deposited with an  $Fe_2O_3$  interlayer using the same conditions used for deposition on  $Al_2O_3$ , a peak corresponding to (111)-oriented  $Fd\bar{3}m$   $Fe_3O_4$  (magnetite) is seen by XRD in Figure 2. On (111) Pt, the wüstite  $Fe_2O_3$  phase is metastable and transitions to magnetite at thicknesses above 2–3 layers.<sup>14,23</sup> These reports are consistent with finding magnetite as a secondary phase rather than other iron oxide phases. As previously reported, magnetite precipitation occurs in these h-ScFeO<sub>3</sub> films deposited on the interlayer. Figure S5a gives an example of an AFM micrograph with faceted islands that occurred in and on thin films processed with an excess of iron. Energy dispersive X-ray spectroscopy (EDS) results of the scanning electron micrograph in Figure S5b corroborate that the faceted islands are iron-rich compared to the rest of the h-ScFeO<sub>3</sub> films. Similar faceted islands have previously been attributed to iron excess in isostructural  $LuFeO_3$ .<sup>25</sup> Furthermore, in the RHEED pattern in Figure S5c, there are dim diffraction streaks that fit to the  $Fe_3O_4$ . The critical issue is not just the formation of a secondary phase but its impact on the surface roughness and conductivity through the thickness of the film. The conductivity of  $Fe_3O_4$  is  $2 \times 10^2 \Omega^{-1} \text{cm}^{-1}$  at room temperature, and therefore would be detrimental in an electronic or optoelectronic device.<sup>26</sup> Due to the formation



**Figure 3.** (a) XRD of a representative h-ScFeO<sub>3</sub> film deposited on a wüstite interlayer with reduced iron flux in the first eight layers; inset rocking curve measurement of the 0004 h-ScFeO<sub>3</sub> reflection. (b) AFM image of the film shown in panel (a). (c) RHEED of the film at the deposition temperature of 900 °C.



**Figure 4.** (a) Scanning transmission electron microscope image of the h-ScFeO<sub>3</sub> interface, iron oxide interlayer, and platinum films taken along the  $[11\bar{2}0]$  h-ScFeO<sub>3</sub> zone axis. Inset is a zoomed-in region of the film at the film–substrate interface with a schematic of the atomic positions overlaid. (b) Electron energy loss spectroscopy of an h-ScFeO<sub>3</sub> film on (111) Pt deposited with an iron oxide interlayer.

of the secondary Fe<sub>3</sub>O<sub>4</sub> phase, it is critical to find a way to reduce the excess iron in these films.

To reduce the excess iron in the ScFeO<sub>3</sub> films with an iron oxide interlayer, the time of iron deposition is reduced by 10% in the first eight deposition cycles after depositing the iron oxide bilayer. This process leads to the disappearance of the iron oxide peaks in the  $2\theta$  scans, as seen in the XRD data for an h-ScFeO<sub>3</sub> film deposited on a wüstite interlayer on (111) Pt at 900 °C in Figure 3a. Furthermore, the 0002 $l$  peaks of h-ScFeO<sub>3</sub> have Laue oscillations, an indication that the films are homogeneous and have smooth interfaces.<sup>27</sup> Rocking curves of the h-ScFeO<sub>3</sub> film deposited with the reduced iron flux on the Fe<sub>2</sub>O<sub>3</sub> interface layer provide further insight into the degree of crystalline orientation. The FWHM of the rocking curve is 0.06°, as seen in the inset of Figure 3a, which is the lowest value reported for h-ScFeO<sub>3</sub> in the literature. Compared to the rocking curves of films with excess iron in Figure S6, this is a 2-fold decrease in rocking curve FWHM. Beyond crystalline orientation, rocking curves of isostructural materials have been used to determine if films are stoichiometric.<sup>25</sup> In a previous study, it was found that in structurally analogous LuFeO<sub>3</sub>, an excess of either cation resulted in a broadening of the rocking, with the FWHM ranging from 0.6 to 1.6°. Therefore, the narrow rocking curve of the h-ScFeO<sub>3</sub> films deposited on platinum with an iron oxide interlayer is an additional indication that these films are near stoichiometry. With the improved rocking curve, there is also a significant reduction in the size and concentration of faceted islands at the film surface, as shown in Figure 3b. The AFM further supports the reduction in the excess of iron. The  $R_a$  decreases from 1.5 to

0.6 nm when depositing with a deficiency of iron in the first layers. Furthermore, in Figure 3c, the Fe<sub>3</sub>O<sub>4</sub> diffraction pattern is not visible in the RHEED of an exemplary film, showing that the formation of surface iron oxides is suppressed. Overall, depositing with a 10% reduction of iron in the first eight cycles not only reduces iron oxide formation but also enhances the crystallinity of the h-ScFeO<sub>3</sub>.

Scanning transmission electron microscopy (STEM) provides further evidence for the interlayer stabilization of crystalline h-ScFeO<sub>3</sub> on (111) Pt, as seen in Figure 4a. The layered structure of scandium and iron in the h-ScFeO<sub>3</sub> phase is clearly visible by STEM. The down–down–up displacement of the scandium atoms is also visible in the image, which is the key feature that defines the structural distortion along the 6-fold rotational axis in the  $P6_3cm$  phase of ScFeO<sub>3</sub>. H-ScFeO<sub>3</sub> is known to have two distinct polarization states, arising from up–up–down polar and down–down–up polar distortions of the scandium lattice. Both polar distortions are observed via STEM (Figure S7), indicating that the two polarization directions have comparable energies, as expected for a ferroelectric material. A similar domain wall between the two polarization directions was observed in h-ScFeO<sub>3</sub> deposited on the La<sub>0.8</sub>Sr<sub>0.2</sub>MnO<sub>3</sub> substrates. Microscopic polarization switching was assessed using piezoresponse force microscopy (PFM) following a poling procedure described in ref 28. Two stable polarization states were measured 30 min after poling, from the +9 and −9 V biases applied to different regions of an exemplary film, as shown in Figure S8. Although some backswitching was observed, the majority of the poled regions retain polarization. The observed switchable polarization of h-

ScFeO<sub>3</sub> observed by PFM is consistent with previous measurements of ferroelectricity in this material and other isostructural materials.<sup>1,29,30</sup>

In prior studies, a common limitation in rare-earth hexagonal ferrites and manganites is that the structural distortion is not present in the first couple of layers due to interfacial clamping from the substrate.<sup>5,9,11</sup> In the films deposited on the iron oxide interlayer, structural distortion is visible in the first layer of scandium in the film. The structural distortion throughout the film is a further indication of the importance of interlayer design for scaling down the thickness of h-ScFeO<sub>3</sub>.<sup>11</sup> Furthermore, the STEM images provide evidence of an intentionally deposited iron oxide bilayer. In Figure 4b, the iron and scandium composition of the atomic layers is determined using electron energy loss spectroscopy, showing the layered structure of h-ScFeO<sub>3</sub>. Analysis of the Fe-L<sub>2,3</sub> edge (Figure S9) shows no change in the onset energy of the L<sub>3</sub> edge between the interlayer and the h-ScFeO<sub>3</sub> film, and the fine structure in both regions is consistent with the Fe<sup>3+</sup> oxidation state.<sup>31</sup> While the wüstite phase has an Fe<sup>2+</sup> oxidation state in bulk, a wüstite phase with a metastable Fe<sup>3+</sup> oxidation state has been observed on platinum.<sup>21,23</sup> The oxidation state of the intentionally deposited interlayer matches the oxidation state in h-ScFeO<sub>3</sub>, which likely causes the high crystalline quality in the films in this work. This work demonstrates that interlayers are critical in expanding the deposition of hexagonal ferrites to other substrates due to a lack of commercial substrates with an epitaxial match.

Collectively, the XRD, STEM, and RHEED results all indicate that a wüstite interlayer is critical to the stabilization of metastable h-ScFeO<sub>3</sub>. The stabilization of the phase was observed only when this interlayer was deposited, and the structural distortion in the first layer is an indication of the reduced interfacial clamping. All films deposited using the interlayer stabilization method in this study resulted in h-ScFeO<sub>3</sub> phase stabilization for 17 subsequent depositions when depositing ScFeO<sub>3</sub> between 850 and 900 °C, demonstrating the reproducibility of this method. For conductive substrates such as platinum, the interlayer must be specifically designed and intentionally added, whereas on substrates such as sapphire, an interlayer forms spontaneously. The difference in stabilization approach on platinum compared to Al<sub>2</sub>O<sub>3</sub> is because FeO is stable on (0001) Al<sub>2</sub>O<sub>3</sub> when depositing at temperatures above 250 °C and with an oxygen atmosphere,<sup>22,23</sup> while on (111) Pt an iron layer must be initially deposited at room temperature and subsequently oxidized.<sup>14,15</sup> While the thickness and crystal structure match interlayers observed in thin films of h-ScFeO<sub>3</sub> and h-LuFeO<sub>3</sub> formed during pulsed laser deposition, the oxidation state of the interlayer phase does not match, either due to different interactions with the substrate or the change in deposition conditions.<sup>8,21</sup> The STEM images show that the structural distortion of the scandium atoms is present in the first layer (and subsequent scandium layers), which was not previously observed by RHEED of h-ScFeO<sub>3</sub> deposited by pulsed laser deposition.<sup>5</sup> The interlayer deposition procedure should be tested on thinner films (i.e., only a couple of unit cells) to test whether the structural distortion is present at or near the monolayer limit, as has been observed in LuFeO<sub>3</sub> films deposited on SrCo<sub>2</sub>Ru<sub>4</sub>O<sub>11</sub> substrates.<sup>11</sup> The Fe<sub>2</sub>O<sub>3</sub> phase used to stabilize h-ScFeO<sub>3</sub> is also stable on (001) Cu, (0001) Ru, and other conductive substrates, expanding the viable bottom electrodes and substrate materials for the stabilization of rare-

earth hexagonal ferrites.<sup>32</sup> While deposition on oxide substrates has been critical to understand the fundamental properties of ScFeO<sub>3</sub>, the expanded substrates available for phase stabilization from this process will enable multiferroic memory and magnetoelectric sensing. The structural compatibility of h-ScFeO<sub>3</sub> with the iron oxide bilayers of varied oxidation states indicates that a similar superlattice could be formed to that of LuFeO<sub>3</sub>/LuFe<sub>2</sub>O<sub>4</sub>, a room temperature multiferroic.<sup>8,33</sup> There also exists an isostructural *Fm3m* phase of MnO with similar lattice parameters compared to FeO.<sup>34</sup> Therefore, the same designed interlayer approach could be applied to rare-earth manganites using MnO as an interlayer. The method to stabilize h-ScFeO<sub>3</sub> described in this work provides a pathway to stabilizing other hexagonal rare-earth materials and can be applied to a wide range of substrate materials with an interlayer approach.

## CONCLUSIONS

The development of a wüstite Fe<sub>2</sub>O<sub>3</sub> interlayer enables the stabilization of the metastable *P6<sub>3</sub>cm* phase of ScFeO<sub>3</sub> on conductive (111) Pt. Developing the interlayer is critical, as the optimal conditions found for film deposition on Al<sub>2</sub>O<sub>3</sub> led to films with the ground state bixbyite structure upon depositing directly on (111) Pt. The interlayer enables the stabilization of 0001-oriented *P6<sub>3</sub>cm* ScFeO<sub>3</sub>, improving the rocking curve FWHM from 0.4 to 0.06°. While Fe<sub>3</sub>O<sub>4</sub> precipitates can form at the surface, these were reduced by depositing a deficiency of iron in the subsequent layers. The crystallinity of the h-ScFeO<sub>3</sub> thin films is further confirmed by STEM, where structural distortion of the scandium lattice is present through the thickness of the film. The oxidation state of the iron interlayer is found to be Fe<sup>3+</sup>, in contrast to the expected oxidation state of wüstite (Fe<sup>2+</sup>). Overall, the method developed here is an ideal interlayer to stabilize h-ScFeO<sub>3</sub> and other hexagonal ferrites on conductive substrates to explore the magnetoelectric applications of h-ScFeO<sub>3</sub>.

## METHODS

ScFeO<sub>3</sub> films were deposited by molecular beam epitaxy (MBE) (Veeco Gen10) at the NSF PARADIM MBE Facility at Cornell University. Initial experiments focused on the deposition of h-ScFeO<sub>3</sub> on Al<sub>2</sub>O<sub>3</sub> because this substrate has previously been shown to stabilize h-ScFeO<sub>3</sub>, despite having a lattice mismatch of −17.1%.<sup>8</sup> The single-crystal sapphire (0001) Al<sub>2</sub>O<sub>3</sub> substrates (CrysTec, GmbH) were annealed in the MBE chamber at 1500 °C to remove surface contamination and improve surface smoothness. The substrates were then cooled to the deposition temperature and subsequently allowed to equilibrate at that temperature for 20 min prior to thin film deposition. For thin film growth, the substrates were heated to temperatures ranging from 500 to 1100 °C, using Epiray's THERMALAS heater featuring a Coherent 10.6 μm CO<sub>2</sub> laser. The substrate temperature was monitored by using a Heitronics optical pyrometer operating at 7.5 μm.

Elemental scandium and iron were loaded into tungsten and alumina crucibles, respectively, and supplied from independent medium temperature effusion cells. A quartz crystal microbalance (QCM) was used to provide preliminary flux calibrations. Since QCMs often have an error above 10%, a binary oxide calibration was also used to determine the flux rates within an accuracy of <1% error for the iron and scandium, using a process described in reference 35. The binary oxide calibration was performed by depositing films of Sc<sub>2</sub>O<sub>3</sub> and Fe<sub>3</sub>O<sub>4</sub> and using the film thickness of each oxide, determined by X-ray reflectivity (XRR), to calibrate the elemental flux rate. XRR was conducted on a Malvern Analytical Empyrean with a copper Kα source (λ = 1.5406) with a four-bounce Ge (220)

monochromator, with a step size of  $0.02^\circ$  with a speed of  $4^\circ \text{ min}^{-1}$ . The thickness was then calculated using the spacing of the Kiessig fringes using the Smartlab Studio II software (Rigaku). An equal flux rate of iron and scandium of  $2.5 \times 10^{13} \text{ atoms cm}^{-2} \text{ s}^{-1}$  was targeted for all depositions, and the effusion cell temperature was adjusted until the flux was measured below 2% deviation.

Figure S10a,b shows the XRR data taken for thin films of (111)  $Ia\bar{3}$   $\text{Sc}_2\text{O}_3$  and (001)  $R\bar{3}c$   $\text{Fe}_2\text{O}_3$ , respectively. The thickness and density for each film are listed in Table S1 that were used to calculate the flux rate and deposition timing for each sample. The flux of iron is calculated to be  $2.53 \times 10^{15} \text{ atoms cm}^{-2} \text{ s}^{-1}$  and the flux of scandium is calculated to be  $2.48 \times 10^{13} \text{ atoms cm}^{-2} \text{ s}^{-1}$ . Layer timing was then calculated using the planar atomic density of h- $\text{ScFeO}_3$ , which is  $1.07 \times 10^{15} \text{ atoms cm}^{-2}$  for both scandium and iron.<sup>17</sup>

Once the individual flux rates were determined, the  $\text{ScFeO}_3$  film deposition occurred in discrete layers of scandium and iron, following a methodology similar to that described in reference 7. The layer timing for  $\text{ScFeO}_3$  film deposition was set to alternate with the deposition of scandium and iron to target the layered structure of the  $P6_3cm$  phase of  $\text{ScFeO}_3$ . The shutter timing was adjusted to account for any variations in the measured flux rate compared to the targeted rate ( $2.5 \times 10^{13} \text{ atoms cm}^{-2} \text{ s}^{-1}$ ) to keep the number of atoms deposited per layer consistent. The base pressure of the chamber was below  $2 \times 10^{-7}$  Torr prior to all depositions. An oxidant partial pressure of  $1 \times 10^{-6}$  Torr with 80%  $\text{O}_3$  was used for all depositions of  $\text{ScFeO}_3$ . The  $\text{ScFeO}_3$  film phase formation was monitored by in situ reflection high-energy electron diffraction (RHEED) (STAIB Instruments) operating at 14 kV and 1.4–1.5 A during film growth and subsequent cooling.

For the deposition onto conductive substrates, a layer of platinum was deposited on annealed (0001)  $\text{Al}_2\text{O}_3$  single-crystal substrates (Sapphire, CrysTec, GmbH) by electron beam deposition prior to the  $\text{ScFeO}_3$  film deposition without breaking the vacuum between depositions. Platinum was chosen because (111) platinum offers a conductive substrate and because it can be used to target the desired interlayer of (111) wüstite. Further information on the deposition conditions for the platinum layer can be found in reference 36. The resulting (111) platinum films exhibit a narrow rocking curve full width at half-maximum of  $0.004^\circ$ , a surface roughness of 0.20 nm, and conductivity of  $8.99 \times 10^6 \text{ S/m}$ .

A wüstite iron oxide interlayer is used to stabilize h- $\text{ScFeO}_3$  due to the overlap in the oxygen sublattice and low epitaxial strain ( $-3.7\%$ ). The deposition process used to target the wüstite iron oxide interlayer was developed based on reference 14. Iron was initially deposited at room temperature by MBE onto (111) Pt substrates, and then, the films were heated to  $600^\circ \text{C}$  in an oxidant atmosphere of  $1 \times 10^{-7}$  Torr of 80%  $\text{O}_3$  to target an  $\text{Fe}^{3+}$  oxidation state. After the oxidation step, the temperature of the substrates was increased to  $900^\circ \text{C}$  for the deposition of h- $\text{ScFeO}_3$  by using alternating scandium and iron fluxes for the rest of the deposition.

The morphology of the films was determined from atomic force microscopy (AFM) using an Asylum Research Cypher ES with Arrow UHF tips (NanoWorld, < 10 nm radius, silicon with reflective aluminum coating). A tapping AFM mode was used at a scan rate of 5 Hz and 512 samples/line. Piezoresponse force microscopy (PFM) images were collected using a Bruker Icon AFM with SCM-PIT (Bruker, <25 nm radius, antimony-doped silicon with 20 nm PtIr coating) probes. DC fields of +9 and  $-9 \text{ V}$  were applied to pole the sample with a scan rate of 0.996 Hz and 256 samples/line. The bottom electrode was grounded by applying silver paint to the side of the sample. To measure the phase and amplitude from the poled sample, an AC of 2 V was applied to the sample with a single frequency below contact resonance, a scan rate of 0.5 Hz, and 512 samples/line. Scanning electron microscopy (SEM) and energy dispersive X-ray spectroscopy (EDS) measurements were taken on the  $\text{ScFeO}_3$  films using a Thermo Axia ChemiSEM. The voltages for SEM and EDS were 20 kV. SEM images were taken with an Everhart-Thornley secondary electron detector. EDS was collected with a TrueSight X EDS detector with a takeoff angle of  $35^\circ$ .

A cross-section of the interface for scanning transmission electron microscopy (STEM) was prepared by using a Thermo Fisher Scientific Helios G4UX focused ion beam. High-angle annular darkfield STEM images were acquired using a Thermo Fisher Scientific Spectra 300 equipped with a cold field emission source operated at an accelerating voltage of 300 kV, a semiconvergence angle of 30 mrad, and a probe current of 60 pA. Electron energy loss spectroscopy was acquired using a Gatan Continuum spectrometer.

## ■ ASSOCIATED CONTENT

### Supporting Information

The Supporting Information is available free of charge at <https://pubs.acs.org/doi/10.1021/acsaelm.5c02616>.

XRD and RHEED of bixbyite  $\text{ScFeO}_3$ , AFM of h- $\text{ScFeO}_3$  on  $\text{Al}_2\text{O}_3$ , XRD and RHEED of bixbyite  $\text{ScFeO}_3$  deposited on Pt, RHEED of the  $\text{Fe}_2\text{O}_3$  interlayer, AFM, SEM, RHEED, and rocking curve of h- $\text{ScFeO}_3$  with excess iron, PFM of h- $\text{ScFeO}_3$ , Fe- $L_{2,3}$  edge EELS spectra, and XRR data and fit parameters used to adjust the deposition timing (PDF)

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## Author Contributions

The manuscript was written through the contributions of all authors. All authors have given approval to the final version of the manuscript.

## Notes

The authors declare no competing financial interest.

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## Supporting Information

### Stabilizing Metastable Rare-Earth Ferrites on (111) Platinum via an Iron Oxide Interlayer

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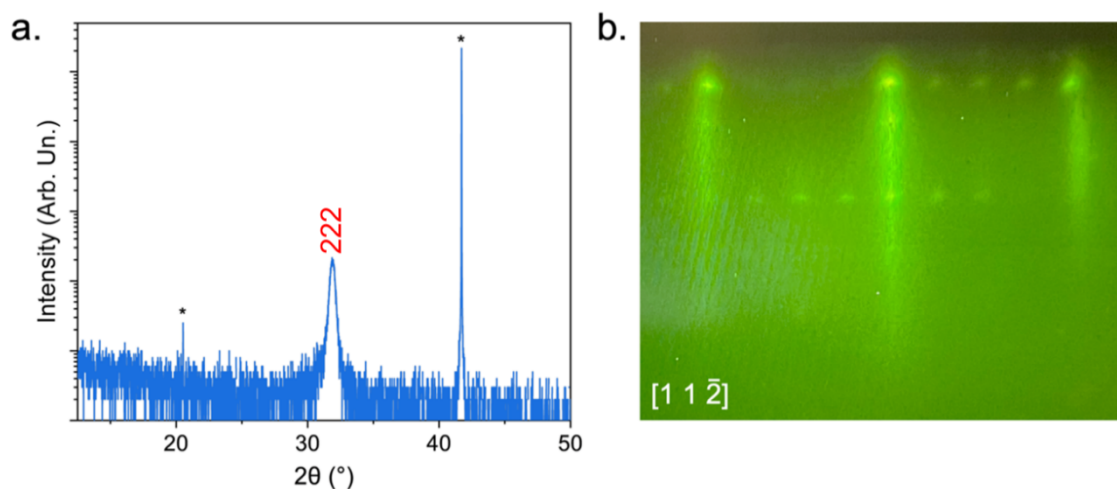
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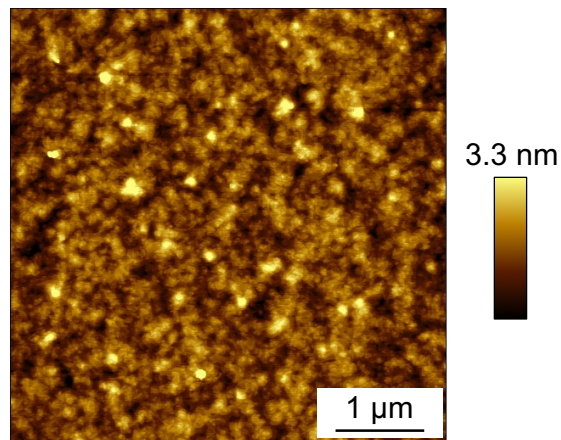
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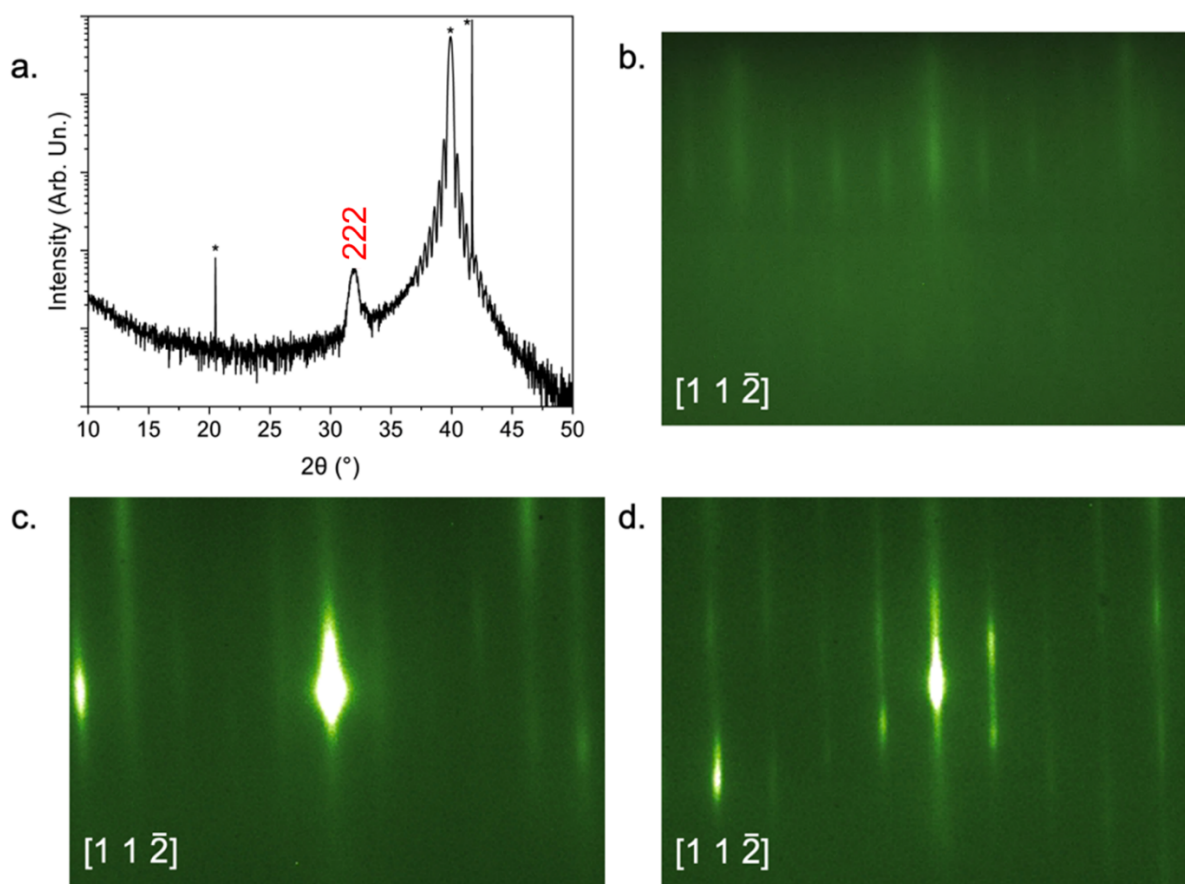
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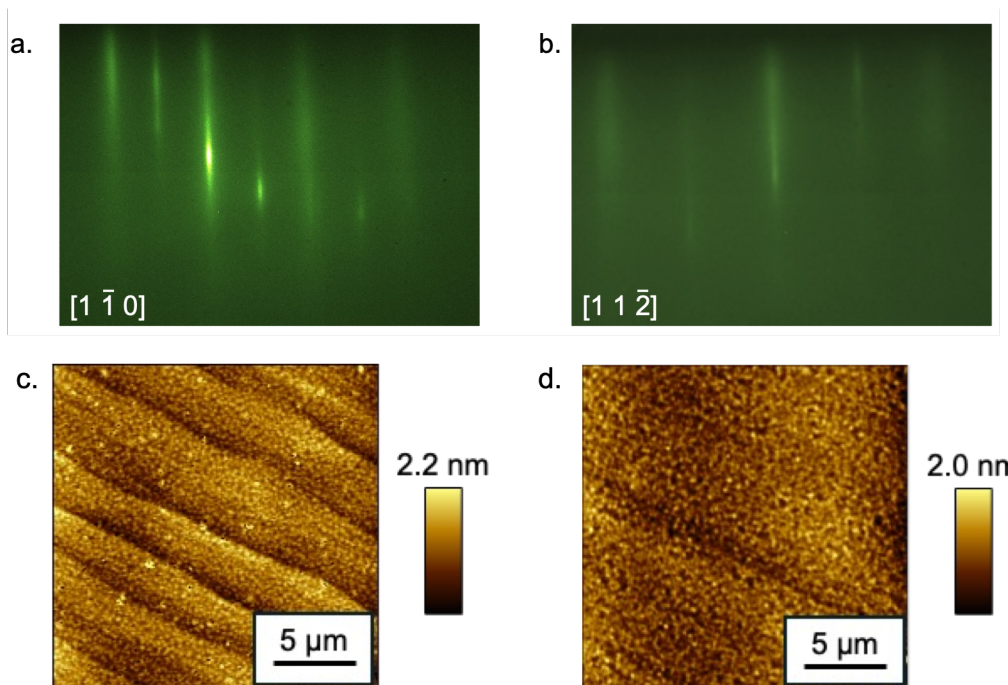
**Figure S1a.** X-ray diffraction and **b.** RHEED of the bixbyite phase of  $\text{ScFeO}_3$  grown on  $\text{Al}_2\text{O}_3$ . The peaks denoted by \* are attributed to  $\text{Al}_2\text{O}_3$  and the peak denoted by **222** is attributed to bixbyite  $\text{ScFeO}_3$  (PDF card #01-083-8521)<sup>33</sup>



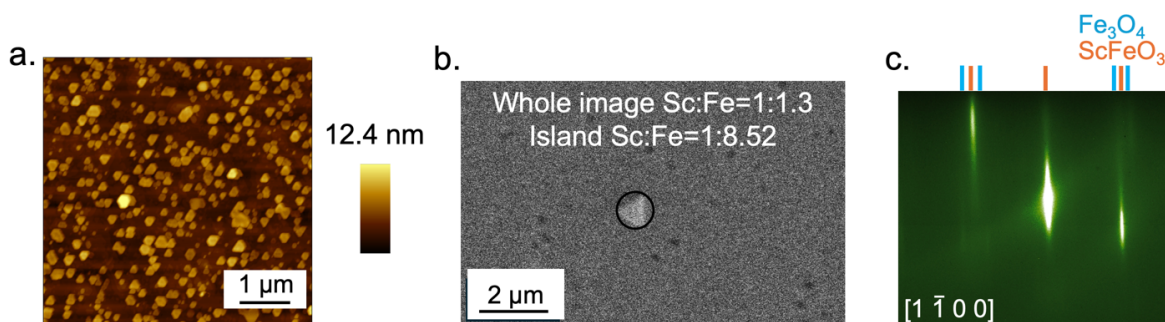
**Figure S2.** 5 x 5  $\mu\text{m}$  AFM scan of  $\text{ScFeO}_3$  grown on  $\text{Al}_2\text{O}_3$ . The average surface roughness ( $R_a$ ) across the image is 0.5 nm.



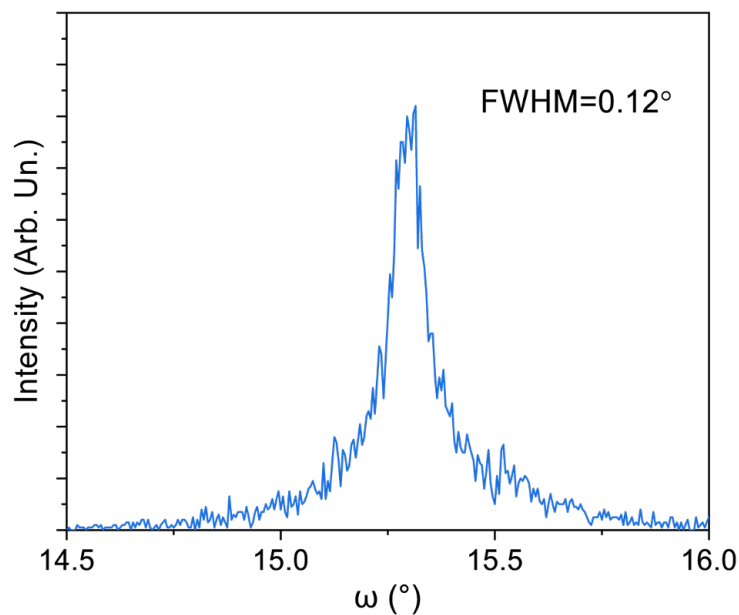
**Figure S3a.** XRD of a  $\text{ScFeO}_3$  film deposited at 900 °C on (111) Pt and **b.** the corresponding RHEED pattern. XRD peak labelled with **222** are fit to the bixbyite phase of  $\text{ScFeO}_3$  and peaks labelled with \* are attributed to the (111) Pt and (0001)  $\text{Al}_2\text{O}_3$ . RHEED of  $\text{ScFeO}_3$  films deposited on (111) Pt at **c.** 700 °C and **d.** 1100 °C.



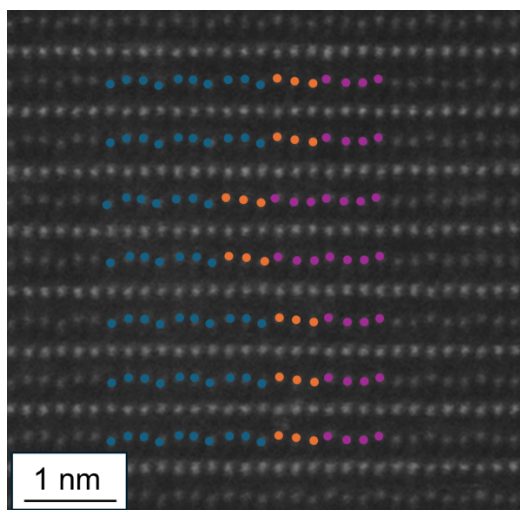
**Figure S4.** RHEED along the **a.**  $[1\bar{1}0]$  and **b.**  $[11\bar{2}]$  of the (111) wüstite structure after oxidation at 600 °C. Representative 20 x 20 μm AFM images of the **c.** Pt substrate and **d.** the iron-oxide interlayer.



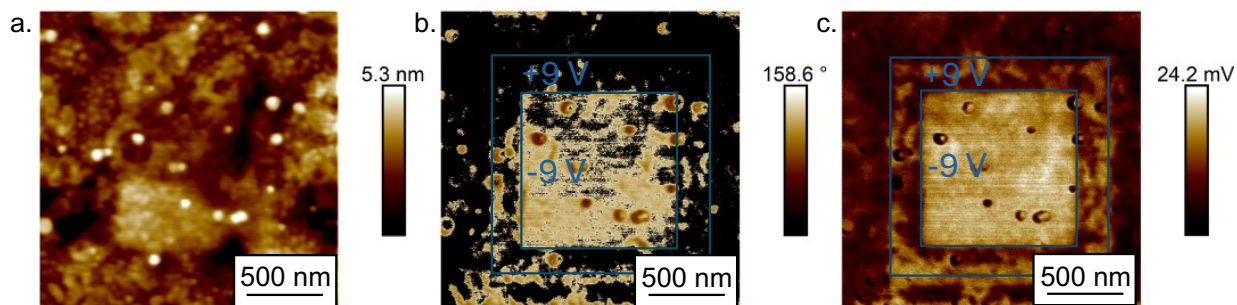
**Figure S5a.** AFM image of a h-ScFeO<sub>3</sub> film on (111) Pt. **b.** SEM micrograph of a representative ScFeO<sub>3</sub> film deposited on platinum. Energy dispersive X-ray spectroscopy (EDS) of the island (circled in black) indicates that the faceted islands are composed primarily of an iron oxide. **c.** RHEED of an h-ScFeO<sub>3</sub> film along the ScFeO<sub>3</sub>  $[1\bar{1}00]$  with an excess of iron at deposition temperature (900 °C).



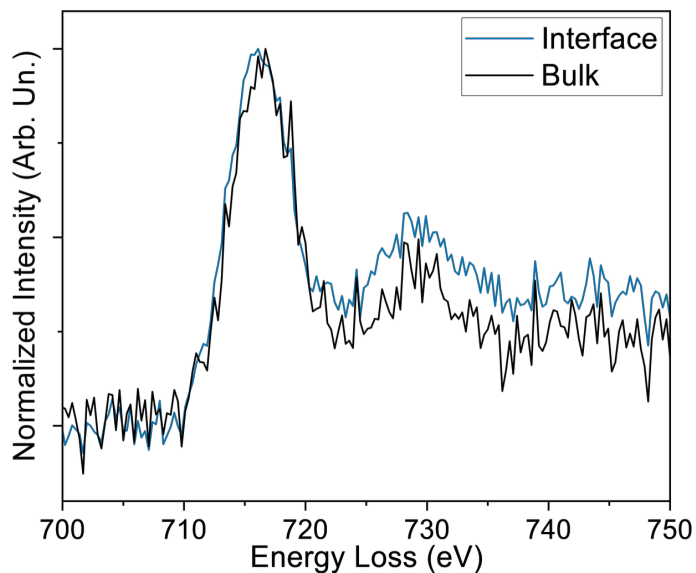
**Figure S6.** Rocking curve of the 0004 reflection of h-ScFeO<sub>3</sub> deposited on two layers of iron, with a measured FWHM of 0.12°.



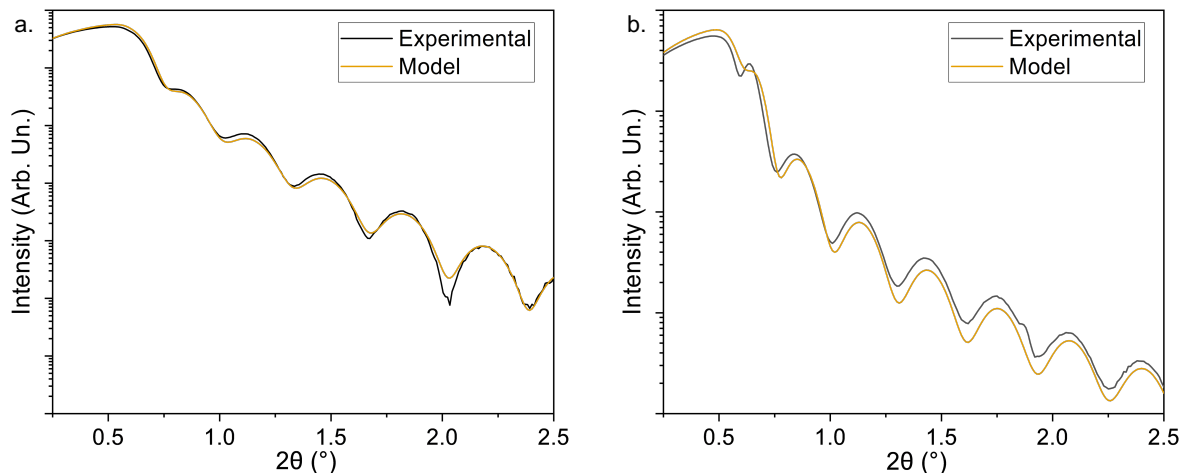
**Figure S7.** Scanning transmission electron micrograph of h-ScFeO<sub>3</sub> with two distinct polarization states. Blue false color contrast shows scandium atoms an up-up-down (upwards polarization vector), orange false color indicates the presumed antipolar distortion between different polarization directions (no net polarization vector), and purple false color contrast shows a down-down-up distortion (downwards polarization vector).



**Figure S8.** Vertical piezoresponse force microscopy of a 25 nm h-ScFeO<sub>3</sub> film on (111) Pt: **a.** topography, **b.** phase, and **c.** amplitude signals over a 2  $\mu\text{m}$  region. An outer 1.5  $\mu\text{m}$  region was poled with +9 V bias and subsequently the inner 1  $\mu\text{m}$  region was poled with -9 V bias. Domain structures were measured 30 minutes after poling.



**Figure S9.** Fe-L<sub>2,3</sub> edge EELS spectra of the ScFeO<sub>3</sub> thin film deposited on an Fe<sub>2</sub>O<sub>3</sub> wüstite interlayer at both the interface and bulk of the film, showing no difference in oxidation state between the iron oxide interlayer and h-ScFeO<sub>3</sub>.



**Figure S10.** X-ray reflectivity measured data as well as the model used to fit the thickness, density, and roughness of the a.  $\text{Fe}_2\text{O}_3$  and b.  $\text{Sc}_2\text{O}_3$  films.

**Table S1.** Fit parameters used to model the Kiessig fringes of the  $\text{Fe}_2\text{O}_3$  and  $\text{Sc}_2\text{O}_3$  films. The R-factor is a measure of the goodness of fit, with a lower R-factor indicating a better fit.

Material	Thickness (nm)	Density ( $\text{g cm}^{-3}$ )	Roughness (nm)	R-factor (%)
$\text{Fe}_2\text{O}_3$	23.1	5.31	1.1	1.1
$\text{Al}_2\text{O}_3$	$\infty$	3.98	0.2	
$\text{Sc}_2\text{O}_3$	26.4	3.79	0.0	1.7
$\text{Y}_2\text{O}_3$ stabilized $\text{ZrO}_2$	$\infty$	5.80	0.4	